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**FACSIMILE COVER SHEET**

To: Special Examiners Group (SPRE) Technology Center 1700	Total Pages Sent: 2 (including cover sheet)
Facsimile Number: 571-273-8300	Transmission Date: September 14, 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

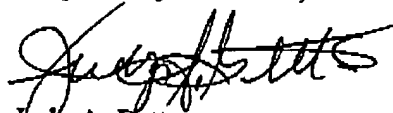
Applicant: Chen, *et al.* Docket No.: TSM6283131RJ  
Serial No: 10/650,886 Art Unit: 1763  
Date Filed: August 28, 2003  
Title: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Request For Status Of Reissue Application (1 page)

Respectfully submitted,



Judy A. Betts  
Legal Assistant

**Confirmation Respectfully Requested**

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SEP 14 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chen, *et al.*  
Filed: 8/28/2003  
Serial No.: 10/650,886  
For: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

Docket No: TSM6283131RI  
Art Unit: 1763  
Examiner: George A. Goudreau

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR STATUS OF REISSUE APPLICATION**


Dear Sir:

The PAIR website indicates that the Issue Revision was completed on July 5, 2005 for this reissue application. Applicants have received no further correspondence from the USPTO regarding the final examination of this reissue application.

Applicants respectfully request confirmation of the status of the final examination of this application and prompt issuance of the reissued patent.

September 14, 2005

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